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APPLICATION NO		FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/815,813	•	04/02/2004	Koichiro Tanaka	0756-7283	9376
31780	7590	05/11/2006		EXAMINER	
ERIC RO	BINSON		CHAMBLISS, ALONZO		
PMB 955	ITIID ANI	7 ST		ART UNIT	PAPER NUMBER
21010 SOU POTOMAG		VA 20165		2814	
				DATE MAILED: 05/11/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

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		Application No.	Applicant(s)	0
		10/815,813	TANAKA ET AL.	
	Office Action Summary	Examiner	Art Unit	
		Alonzo Chambliss	2814	
Period fo	The MAILING DATE of this communication app or Reply	pears on the cover sheet	with the correspondence addr	əss
WHI(- Exte after - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REPLY CHEVER IS LONGER, FROM THE MAILING Donsions of time may be available under the provisions of 37 CFR 1.1 SIX (6) MONTHS from the mailing date of this communication. Operiod for reply is specified above, the maximum statutory period or the reply within the set or extended period for reply will, by statute reply received by the Office later than three months after the mailing ed patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMU 36(a). In no event, however, may will apply and will expire SIX (6) Me, cause the application to become	NICATION. y a reply be timely filed MONTHS from the mailing date of this commendate ABANDONED (35 U.S.C. § 133).	
Status				
1)⊠ 2a)⊟ 3)⊟	Responsive to communication(s) filed on <u>17 Jac</u> This action is FINAL . 2b) This Since this application is in condition for allowar closed in accordance with the practice under E	action is non-final. nce except for formal m	• •	nerits is
Dii4	ion of Claims	ex parto quayro, 1000 c	7.5. 11, 400 0.0. 210.	
4)⊠ 5)⊠ 6)⊠ 7)⊠ 8)□ Applicat 9)⊠	Claim(s) 1-18 and 29-46 is/are pending in the 4a) Of the above claim(s) is/are withdraw Claim(s) 7-18 and 35-40 is/are allowed. Claim(s) 1-4 and 29-32 is/are rejected. Claim(s) 5,6,33 and 34 is/are objected to. Claim(s) are subject to restriction and/o ion Papers The specification is objected to by the Examine The drawing(s) filed on 02 April 2004 is/are: a) Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct	wn from consideration. or election requirement. er. o accepted or b) obdrawing(s) be held in abe	yance. See 37 CFR 1.85(a).	1.121(d).
11)	The oath or declaration is objected to by the Ex	caminer. Note the attact	ned Office Action or form PTO	-152.
12)⊠ a)i	Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Bureau See the attached detailed Office action for a list	s have been received. s have been received in rity documents have be u (PCT Rule 17.2(a)).	n Application No en received in this National St	age
2) ☐ Notic 3) ⊠ Infori	t(s) se of References Cited (PTO-892) se of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) or No(s)/Mail Date 1/17/06	Paper N	w Summary (PTO-413) lo(s)/Mail Date of Informal Patent Application (PTO-19	52)

DETAILED ACTION

Election/Restrictions

1. The previous restriction requirement mailed on 12/13/05 has been withdrawn. Therefore, claims 1-18 and 29-46 are pending in the application.

Priority

2. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

Information Disclosure Statement

3. The information disclosure statement (IDS) submitted on 1/17/06 was filed before the mailing date of the non-final rejection on 4/17/06. The submission is in compliance with the provisions of 37 CFR 1.97. Accordingly, the information disclosure statement is being considered by the examiner.

Drawings

4. The drawings are objected to as failing to comply with 37 CFR 1.84(p)(5) because they include the following reference character(s) not mentioned in the description: 823c, 825c, 826c, 827c, 832a, 835b, 836b, 837b, 838b, 846a, 846b, 846c, 846d, 847a, 858, 974, and 976. Corrected drawing sheets in compliance with 37 CFR 1.121(d), or amendment to the specification to add the reference character(s) in the description in compliance with 37 CFR 1.121(b) are required in reply to the Office action

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to avoid abandonment of the application. Any amended replacement drawing sheet should include all of the figures appearing on the immediate prior version of the sheet, even if only one figure is being amended. Each drawing sheet submitted after the filing date of an application must be labeled in the top margin as either "Replacement Sheet" or "New Sheet" pursuant to 37 CFR 1.121(d). If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

Specification

5. The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed. The following title is suggested: "METHOD OF FABRICATING SEMICONDUCTOR DEVICE UTILIZING LASER IRRADIATION".

Claim Rejections - 35 USC § 102

6. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

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7. Claims 1-4 and 29-32 are rejected under 35 U.S.C. 102(e) as being anticipated by Yamazaki et al. (US 6,700,096).

The applied reference has a common assignee and inventor with the instant application. Based upon the earlier effective U.S. filing date of the reference, it constitutes prior art under 35 U.S.C. 102(e). This rejection under 35 U.S.C. 102(e) might be overcome either by a showing under 37 CFR 1.132 that any invention disclosed but not claimed in the reference was derived from the inventor of this application and is thus not the invention "by another," or by an appropriate showing under 37 CFR 1.131.

With respect to Claims 1-3 and 29-31, Yamazaki discloses irradiating an amorphous semiconductor film (i.e. subject) formed over a substrate with a first pulse laser beam (i.e. YAG laser) and a second pulse laser beam (i.e. YOV₄ laser) relatively moving the subject so that areas which are irradiated with the first pulse laser beam and with the second pulse laser beam are overlapped with each other, wherein oscillations of the first pulse laser beam and the second pulse laser beam are synchronized, and wherein a wavelength of the first pulse laser beam is equal to or shorter than that of visible light (i.e. between 300nm – 700nm), and a wavelength of the second pulse laser beam is longer than that of the first pulse laser beam. Crystallizing the amorphous semiconductor by irradiating the amorphous semiconductor film with a laser beam. Patterning the crystalline semiconductor film into a semiconductor layer. A channel formation region is include at least a part of the semiconductor layer. (see col. 5 lines

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40-55, col. 7 lines 1-50, col. 33 lines 2067, col. 36 lines 63-67, and col. 37 lines 1-6; Figs. 34A-34C and 35A).

With respect to Claims 4 and 32, Yamazaki teaches wherein each of the first pulse laser beam and the second pulse laser beam is shaped into a linear beam (see col. 2 lines 18).

Allowable Subject Matter

- 8. Claims 7-18 and 35-40 are allowed.
- 9. Claims 5, 6, 33, and 34 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

The following is a statement of reasons for the indication of allowance subject matter: the prior art of record does not teach or suggest the combination wherein the first pulse laser beam satisfies an inequality of theta1 greater than or equal to arctan (W1/2d), where theat1 is an incident angle of the first pulse laser beam, W1 is a length of a major axis or a minor axis of the first pulse laser beam, and d is a thickness of the substrate in claims 5 and 33.

The second pulse laser beam satisfies an inequality of theta 2 greater than or equal to arctan (W2/2d), where theat1 is an incident angle of the second pulse laser beam, W2 is a length of a major axis or a minor axis of the second pulse laser beam, and d is a thickness of the substrate in claims 6 and 34.

The first pulse laser beam melt: the semiconductor film, and the second pulse laser beam satisfies (alpha greater than or equal to 10 beta), where alpha denotes an absorption coefficient with respect to a molten state of the semiconductor film, and ;beta denotes an absorption coefficient with respect to a solid state of the semiconductor film along with the other limitation in claim 7.

The first pulse laser beam has a wavelength range of which an absorption coefficient with respect to a solid stat of the semiconductor film is $5x10^3$ /cm or more. The second pulse laser beam has a wavelength of which an absorption coefficient with respect to a solid state of the semiconductor film is $5x10^2$ /cm or less and an absorption coefficient with respect to a molten state of the semiconductor film is $5x10^3$ /cm or more along with the other limitation in claim 13.

Forming a channel formation region including at least a part of the semiconductor layer. The first pulse laser beam has a wavelength range of which an absorption coefficient with respect to a solid stat of the semiconductor film is $5x10^3$ /cm or more. The second pulse laser beam has a wavelength of which an absorption coefficient with respect to a solid state of the semiconductor film is $5x10^2$ /cm or less and an absorption coefficient with respect to a molten state of the semiconductor film is $5x10^3$ /cm or more along with the other limitation in claim 41.

The prior art made of record and not relied upon is cited primarily to show the process of the instant invention.

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Conclusion

10. Any inquiry concerning the communication or earlier communications from the examiner should be directed to Alonzo Chambliss whose telephone number is (571) 272-1927.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the Group receptionist whose telephone number is (703) 308-7956

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system Status information for published applications may be obtained from either Private PMR or Public PMR. Status information for unpublished applications is available through Private PMR only. For more information about the PMR system see http://pair-dkect.uspto.gov. Should you have questions on access to the Private PMR system contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free) or EBC_Support@uspto.gov.

Alonzo Chambliss

Primary Patent Examiner

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AC/April 17, 2006